

CHUCK TABLE AND LASER PROCESSING APPARATUS

ABSTRACT OF THE DISCLOSURE

There is provided a chuck table for holding a workpiece under suction. The chuck table includes a base table having a suction path to be connected to a suction source, a support member that is mounted on the base table and supports the workpiece, and a protective plate disposed so as to cover an upper surface of the support member and to protect the support member. The protective plate has a plurality of through-holes that transmits a suction force from the suction source to the workpiece.

[Fig. 3]